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INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Hiroji AGA et al.			
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U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
(CR)	1	US 6,372,609 B1	04/16/2002	Aga et al.	—	—

FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
(CR)	2	JP B2 3048201 w/abstr. + trans.	03/24/2000	Japan	—	
(CR)	3	JP A 11-307472 w/abstr. + trans.	11/05/1999	Japan	—	—
(CR)	4	JP A 10-242154 w/abstr. + trans.	09/11/1998	Japan	—	—
(CR)	5	EP 1 158 581 A1	11/28/2001	Europe	—	—
(CR)	6	WO 01/15215 A1	03/01/2001	WIPO		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)	
7	UCS Semiconductor Substrate Technology Workshop, "Science in Silicon," Realize publishers, pp. 443-496

EXAMINER <i>Colleen E. Berg</i>	DATE CONSIDERED 04/10/06
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Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.